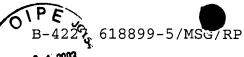
PATENT

(a



IN THE UNITED STATE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in the U.S. Patent Application of:

Inventor(s): Hyoung June KIM

Serial No.:

09/886,940

Filed:

June 21, 2001

Examiner:

Quang T. Van

Art Unit:

3742

For:

METHODS & APPARATUSES FOR HEAT TREATMENT OF SEMICONDUCTOR FILMS UPON THERMALLY SUSCEPTIBLE

NON-CONDUCTING SUBSTRATES

CERTIFICATE OF MAILING

July 29, 2003

Date of Deposit

) I hereby certify that this paper or fee is being deposited with the United States Postal Service as First Class Mail on the date indicated above and is addressed to the Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450.

Mia Kim

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Paper or Fee

Signature of Person Mailing
Paper or Fee

RESPONSE TO RESTRICTION REQUIREMENT

)

Commissioner for Patents P.O. Box 1450
Alexandria, VA 22313-1450

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TECHNOLOGY CENTLE !!

Sir:

In response to the Office Action mailed on May 29, 2003, a response to which is due no later than **September 29, 2003**, Applicants submit the present Election, together with a petition for a one month extension of time pursuant to 37 C.F.R. 1.136(a) and a check in the amount of \$55.00 for the fee set forth in 37 C.F.R. 1.17(a)(1). Please consider the arguments and remarks set forth below, all of which are made without prejudice.

Remarks/Arguments begin on page 2 of this paper.